

10/06/050 PRO

						PATENT NUMBER and ISSUE DATE
U.S. UTILITY Patent Application						
APPL. NO.	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER	
10084050	02/28/2002	438	22	2842	D. LE	
**APPLICANTS:						Hayashi Nobuhiko; Kunisato Tatsuya, Ohbo Hiruki, Yamaguchi Tsutomu;
						3818
**CONTINUING DATA VERIFIED:						<u>None</u>
** FOREIGN APPLICATIONS VERIFIED:						<u>442</u>
JAPAN JP2001-56284 03/01/2001						
PG-PUB		DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>		
Foreign priority claimed				By year <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no		ATTORNEY DOCKET NO
35 USC 119(c) citations met				<input checked="" type="checkbox"/> yes <input type="checkbox"/> no		57610-035
Verifier's acknowledgement ER1-mm-73's initials				<u>DR</u>		
Title: Nitride-based semiconductor element and method of forming nitride-based semiconductor						
U.S. DEPT. OF COMM. PAT. & TM PTO-904 (Rev. 12-94)						

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claims for O.G.
Assistant Examiner		DRAWING	
		Sheets Drawn	Figs. Drawn
ISSUE FEE		Print Fig.	
Amount Due	Date Paid	Primary Examiner	
		Application Examiner	
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	
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